



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Inventor : Roger L. Hipwell, Jr. Appln. No. : 09/707,698 Filed : November 7, 2000 Title : LATERALLY SUPPORTED HANDLE WAFFER FOR THROUGH-WAFER REACTIVE-ION ETCH MICROMACHINING Docket No. : I69.12-0467	Group Art Unit: 1763 Examiner: Olsen, Allan W.
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OCT 14 2003  
TC 1700

**AMENDMENT**

Mail Stop Non-Fee Amendment  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**SENT VIA EXPRESS MAIL**

Express Mail No.: EV 302260735 US

Sir:

This is in response to the Office Action mailed on July 7, 2003 (Paper No. 4). Please amend the above-identified application as follows: